



XA-9590  
PATENT APPLICATION

Response Under 37 C.F.R. 1.116  
Expedited Procedure  
Examining Group 2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Masao SHINOZAKI et al.

Serial No.: 10/002,009                          Group Art Unit: 2814

Filed: December 5, 2001                          Examiner: S. Rao

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING  
A SEMICONDUCTOR DEVICE

\* \* \*

AMENDMENT AFTER FINAL REJECTION

BOX AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed March 4, 2003,  
please amend the above-identified patent application as  
indicated below.

Amendments to the claims begin on page 2 of this  
paper.

Remarks/Arguments begin on page 8 of this paper.

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